

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:      Gordon M. Grivna  
FILED:                              Concurrently Herewith  
FOR:                               SEMICONDUCTOR DEVICE HAVING REDUCED  
                                     CAPACITANCE TO SUBSTRATE AND METHOD  
Date:                               1/5/2004

---

**DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56**

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,  
Gordon M. Grivna et al



ON Semiconductor  
Intellectual Property Dept.  
P.O. Box 62890 - A700  
Phoenix, AZ 85062-2890

Kevin B. Jackson  
Reg. #38,502  
Phone: 602-244-4885  
Fax: 602-244 3169

Customer #: 27255

<b>Form PTO-1449</b>  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b> ( Use Several Sheets If Necessary)	ATTY. DOCKET NO.	SERIAL NO.
	ONS00470	
	APPLICANT Gordon M. Grivna	
	FILING DATE	GROUP
	Concurrently Herewith	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing date (If appropriate)
AA	6 6 6 1 0 6 8	12/9/2003	Durham et al	H01L	21/20	
AB	5 7 4 2 0 9 1	4/21/1998	Hebert	H01L	29/76	
AC	5 8 4 4 2 9 9	12/1/1998	Merrill et al.	H01L	29/00	
AD	6 1 8 0 9 9 5	1/30/2001	Hebert	H01L	29/00	
AE	6 2 2 1 7 2 7	4/24/2001	Chan et al.	H01L	21/20	
AF	6 3 0 7 2 4 7	10/23/2001	Davies	H01L	29/00	
AG	2003 0 1 4 6 4 9 0	8/7/2003	Averett et al.	H01L	29/00	
AH						
AI						
AJ						
AK						
AL						
AM						

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document #	Date	Country	Class/subclass	Translation Yes - No
AN					
AO					
AP					
AQ					
AR					

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AS	
AT	
AU	
AV	
AW	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.